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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1434**
Tetsuroh NAKAMURA et al. : Attorney Docket No. 2005_0717A
Serial No. 10/533,392 : Group Art Unit 2853
Filed April 29, 2005 : Examiner Sarah Al-Hashimi

LIGHT SOURCE FOR IMAGE WRITING
APPARATUS AND PRODUCTION METHOD
FOR LIGHT SOURCE

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Restriction Requirement of July 21, 2006.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a light source of image writing apparatus and image writing apparatus by claims 1-39.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Tetsuroh NAKAMURA et al.

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